





Applicant(s): Finarov, Moshe

Assignee: Nova Measuring Instruments

Title: APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING

POLISHING

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Attn: Official Draftsperson

ASSISTANT COMMISSIONER FOR PATENTS

Washington, D. C. 20231

SUBMISSION OF FORMAL DRAWINGS

Dear Sir:

539136 v1

Applicant submits(7) sheets of formal drawings, consisting of Figures 1, 2, 3, 4, 5, 6, 7, 8, 9, 10, 11, 12, and 13, in the above-named application. If there are any questions regarding these drawings, please call the undersigned at (408) 453-9200.

Attorney for Applicant(s)

Date of Signature

Respectfully submitted,

David W. Heid

Attorney for Applicant(s)

Reg. No. 25,875